

# Studies on the CMS Tracker Upgrade Project

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$$\frac{dN}{dt} = \sigma L$$

**Luminosity Depends only  
on the machine!!**

To have a greater event rate at LHC an upgrade is needed.

**sLHC:**

**super Large Hadron Collider**

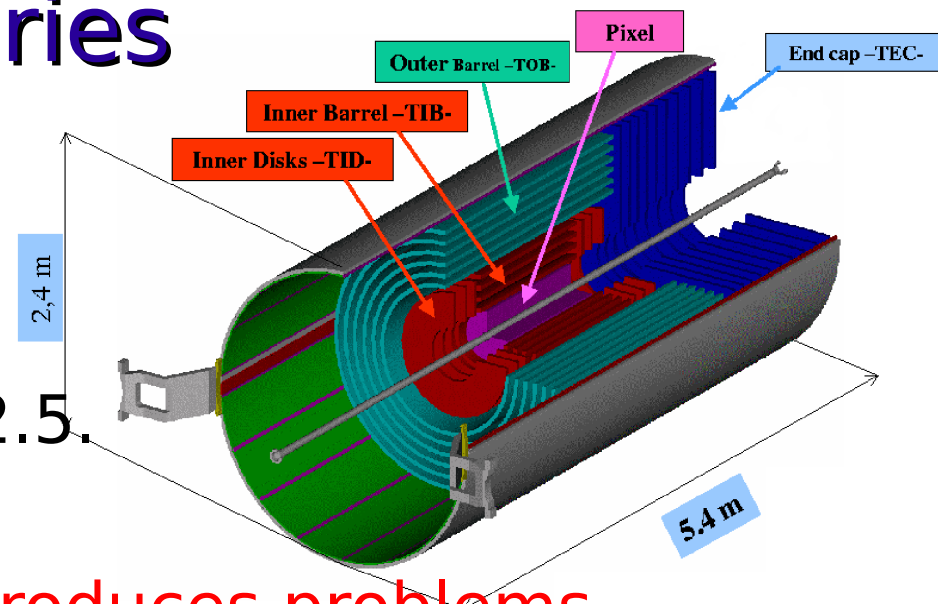
$$L = 10^{34} \text{ cm}^{-2} \text{ s}^{-1} \rightarrow 10^{35} \text{ cm}^{-2} \text{ s}^{-1}$$

## **Principle aim - MORE STATISTICS**

- improved accuracy of SM parameters;
- extend discovery in high mass regions;
- improve sensitivity to rare processes.

## Silicon detector system - measures trajectories

- Barrel:
  - Inner pixel layer;
  - outer microstrip layer.
- Endcaps: coverage up to  $|\eta| < 2.5$ .



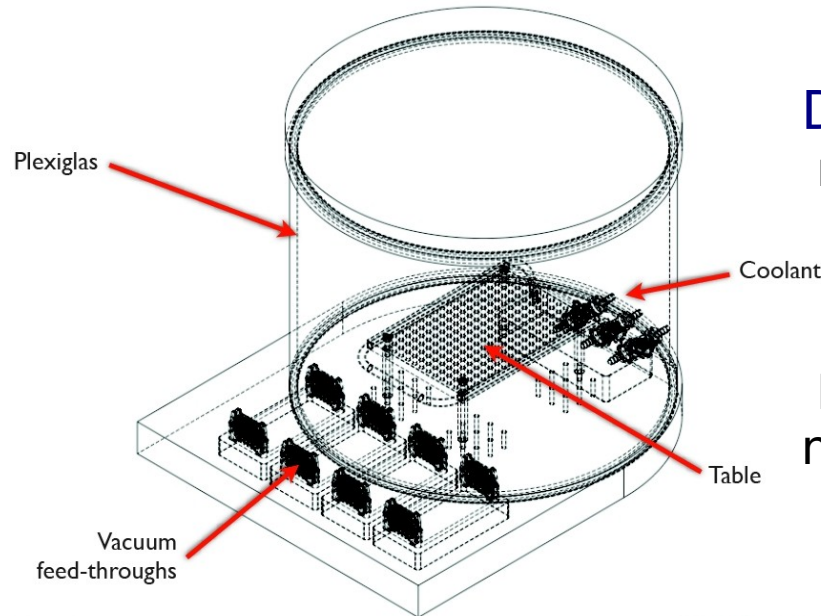
## Large luminosity increase introduces problems

- Radiation damage:
  - lower temperature required to have higher radiation hardness → new cooling system
- Over occupancy:
  - Higher granularity required → more electronics, more material, more unwanted interactions

# Prototypes cooling efficiency test setup

New detector module design needed →

## Set up a Prototype Test Lab



### Design goals:

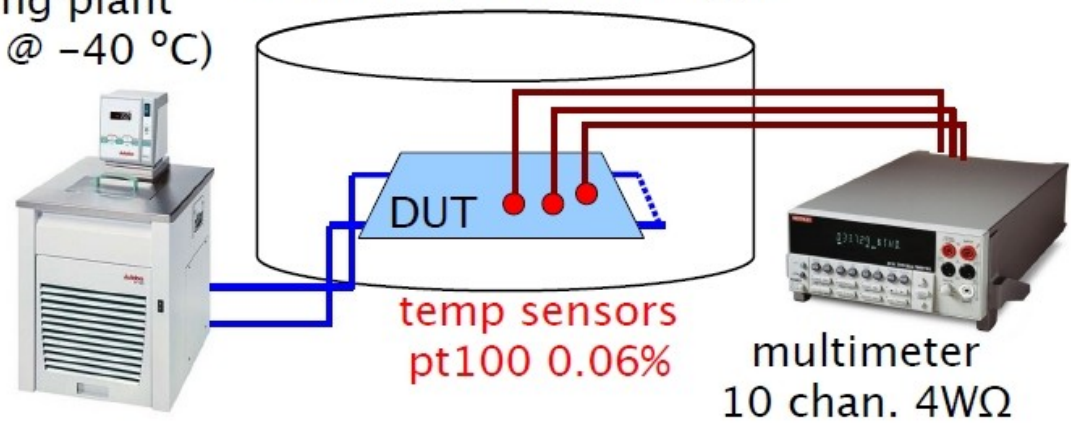
measure cooling efficiency of test structures and module prototypes;  
possibility of vacuum evacuation to determine influence of convection;  
High precision temperature measurements.

### Cooling:

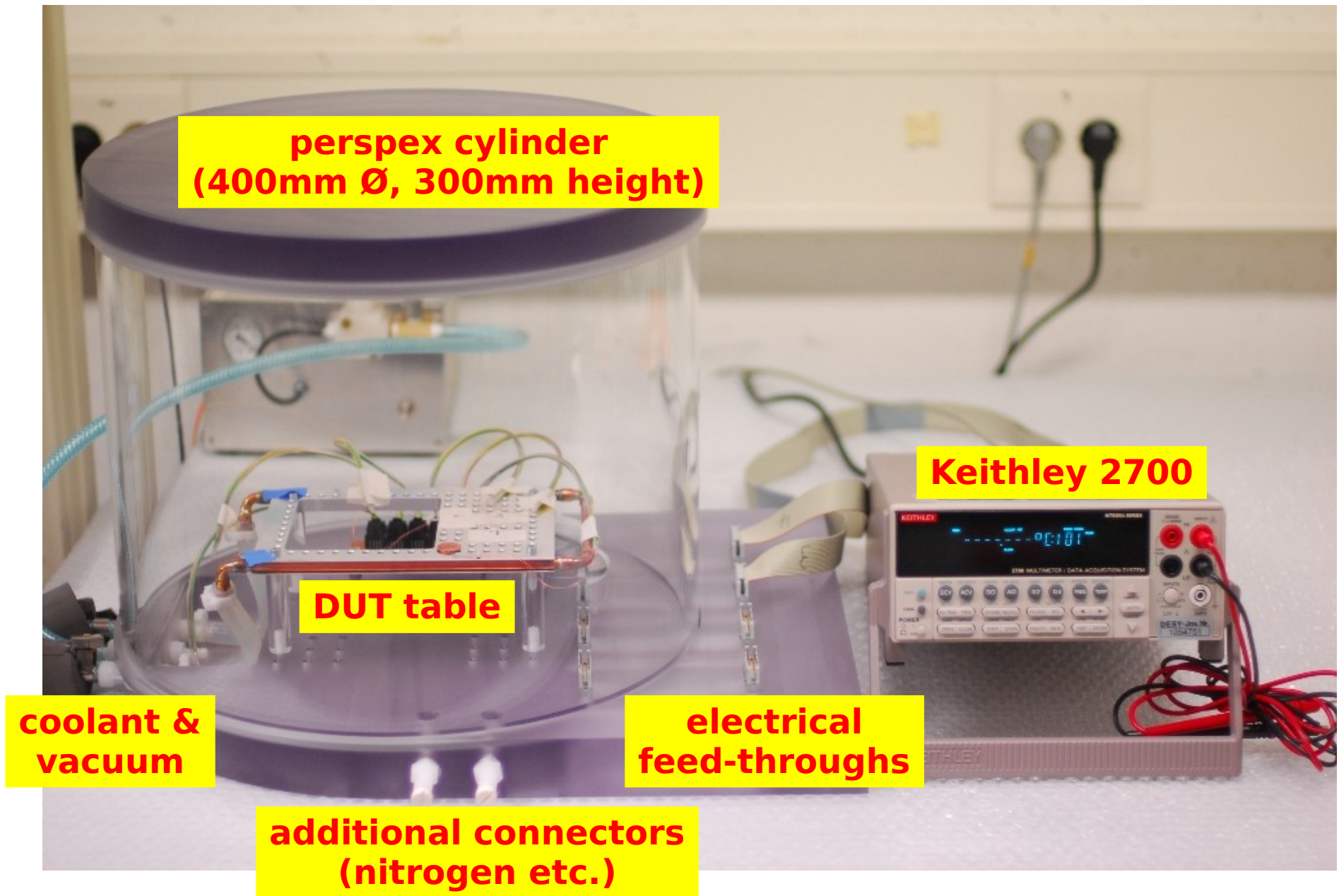
conventional chiller  
(Julabo FP50-MC)  
160W cooling power @ -40°C  
0.45 bar+  
Coolant: silicon oil

cooling plant  
(160W @ -40 °C)

perspex vacuum cylinder  
400mm Ø, 300mm height

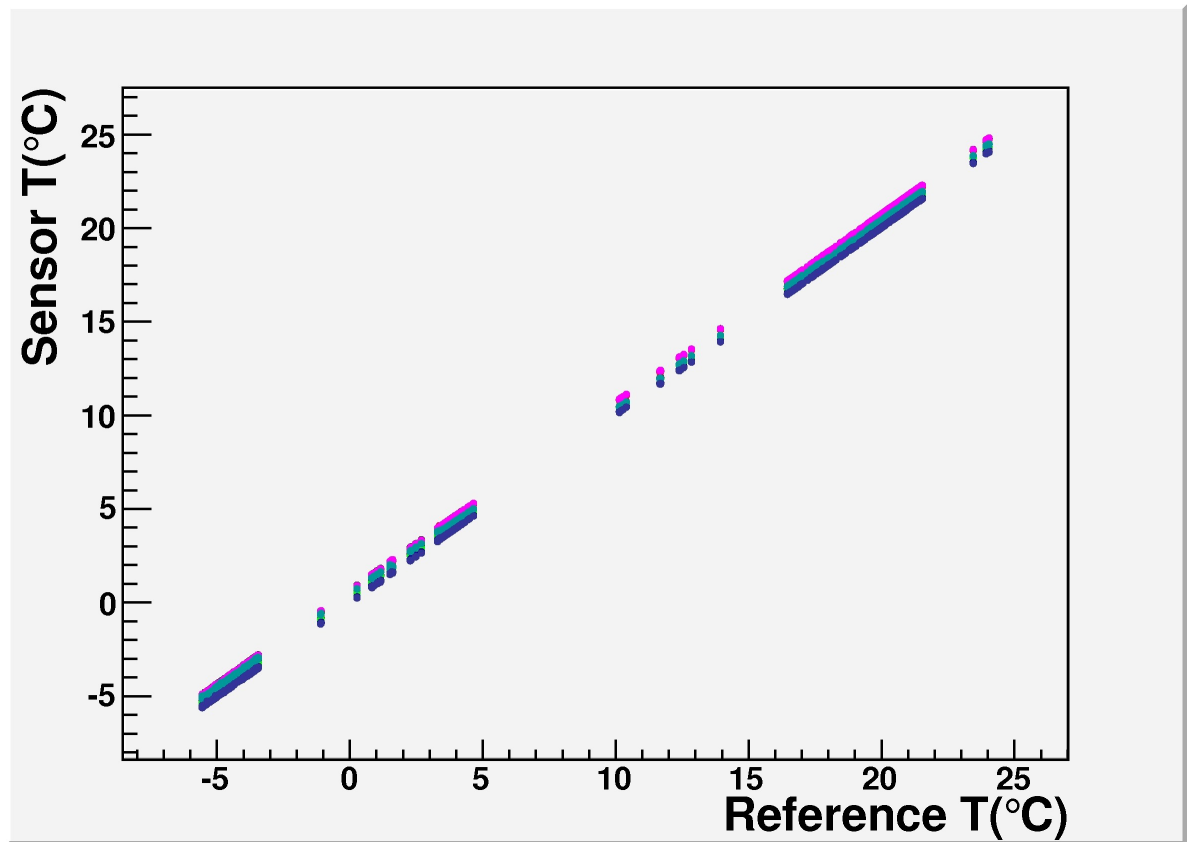
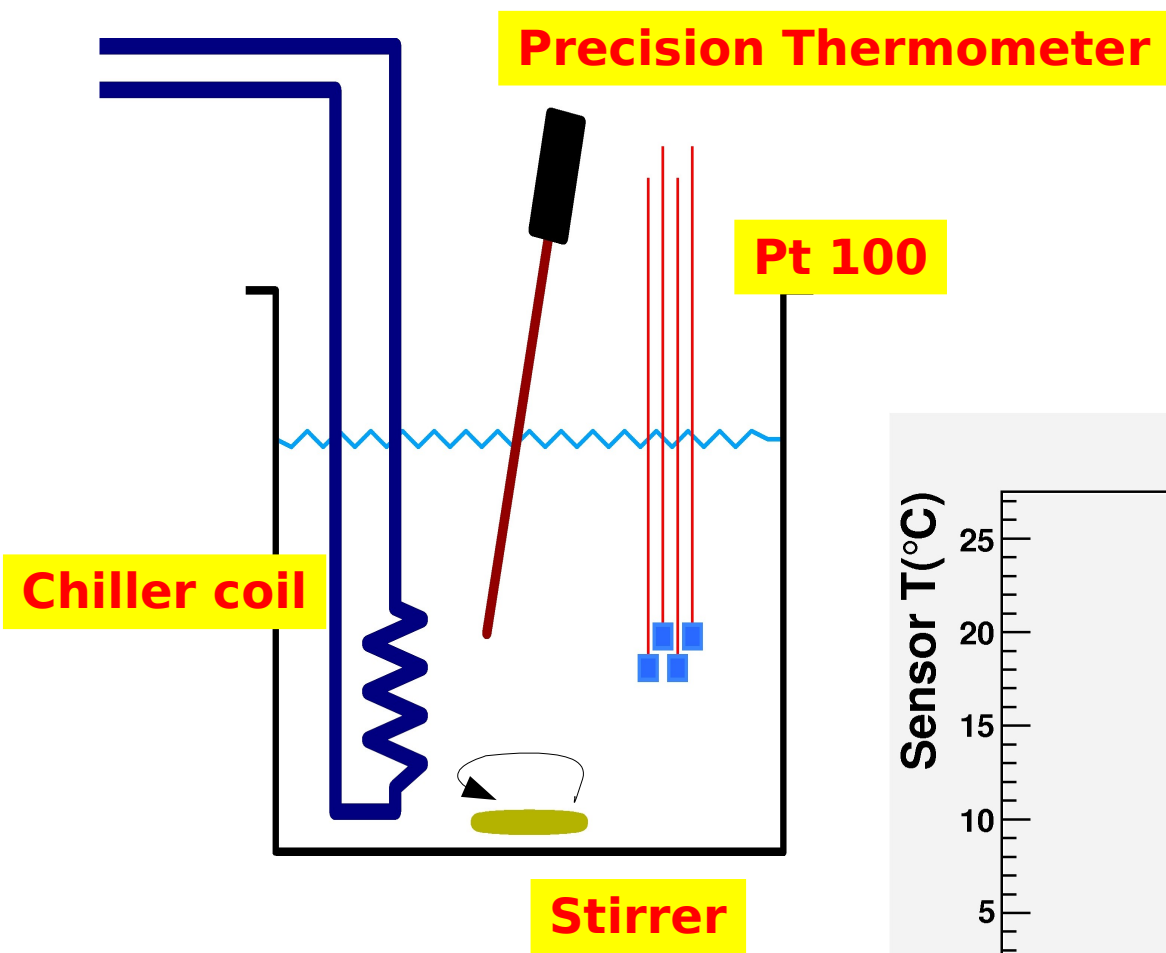


# Prototypes cooling efficiency test setup

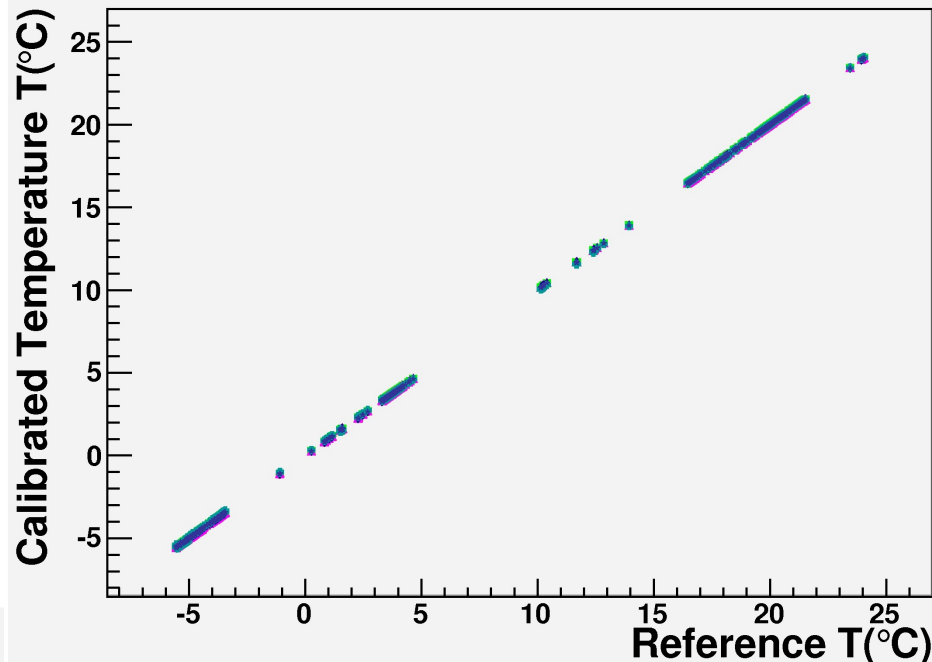




# Sensor calibration setup

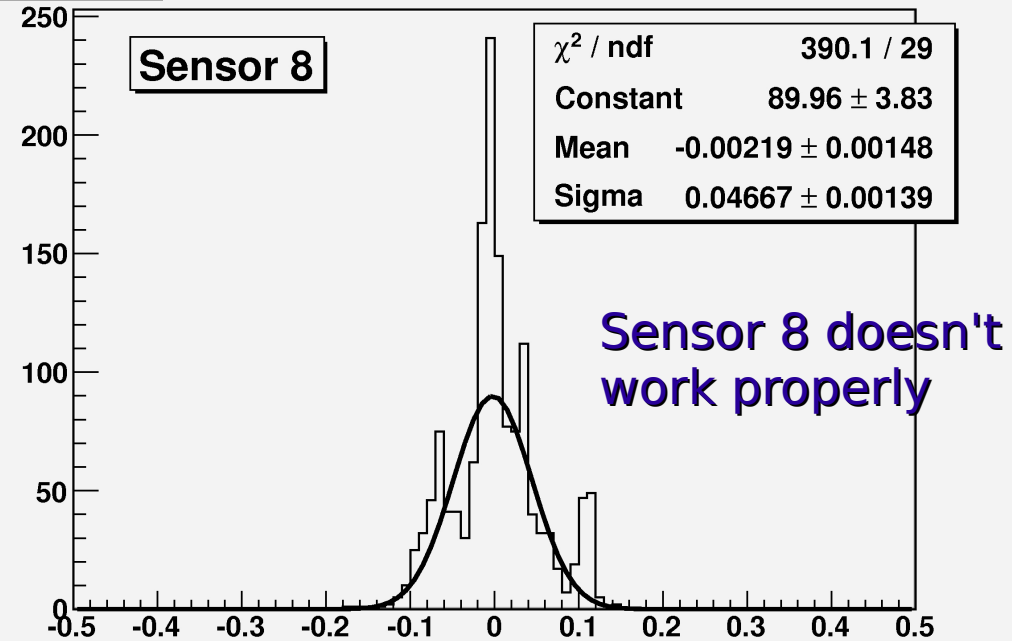
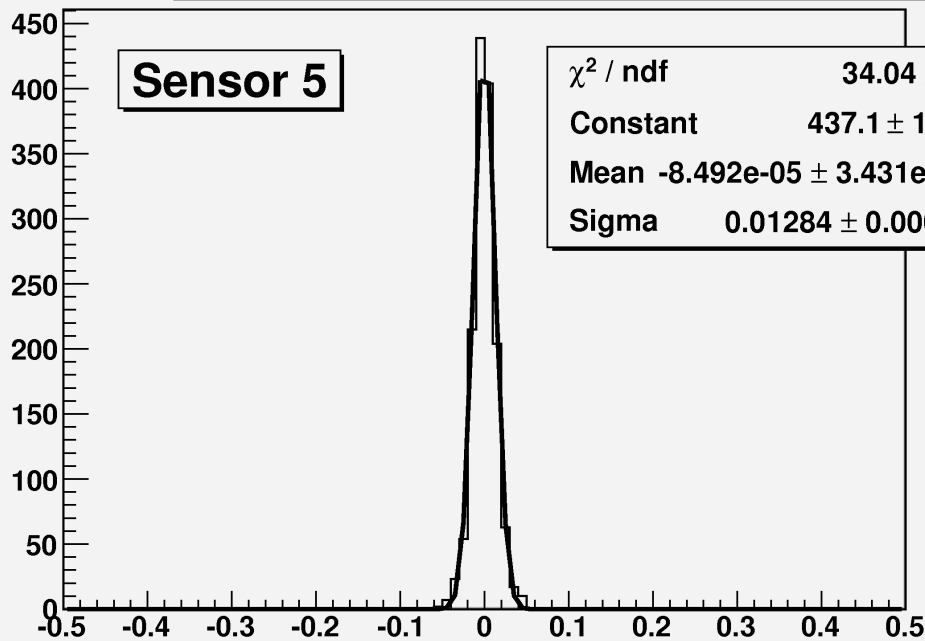


# Sensor calibration results



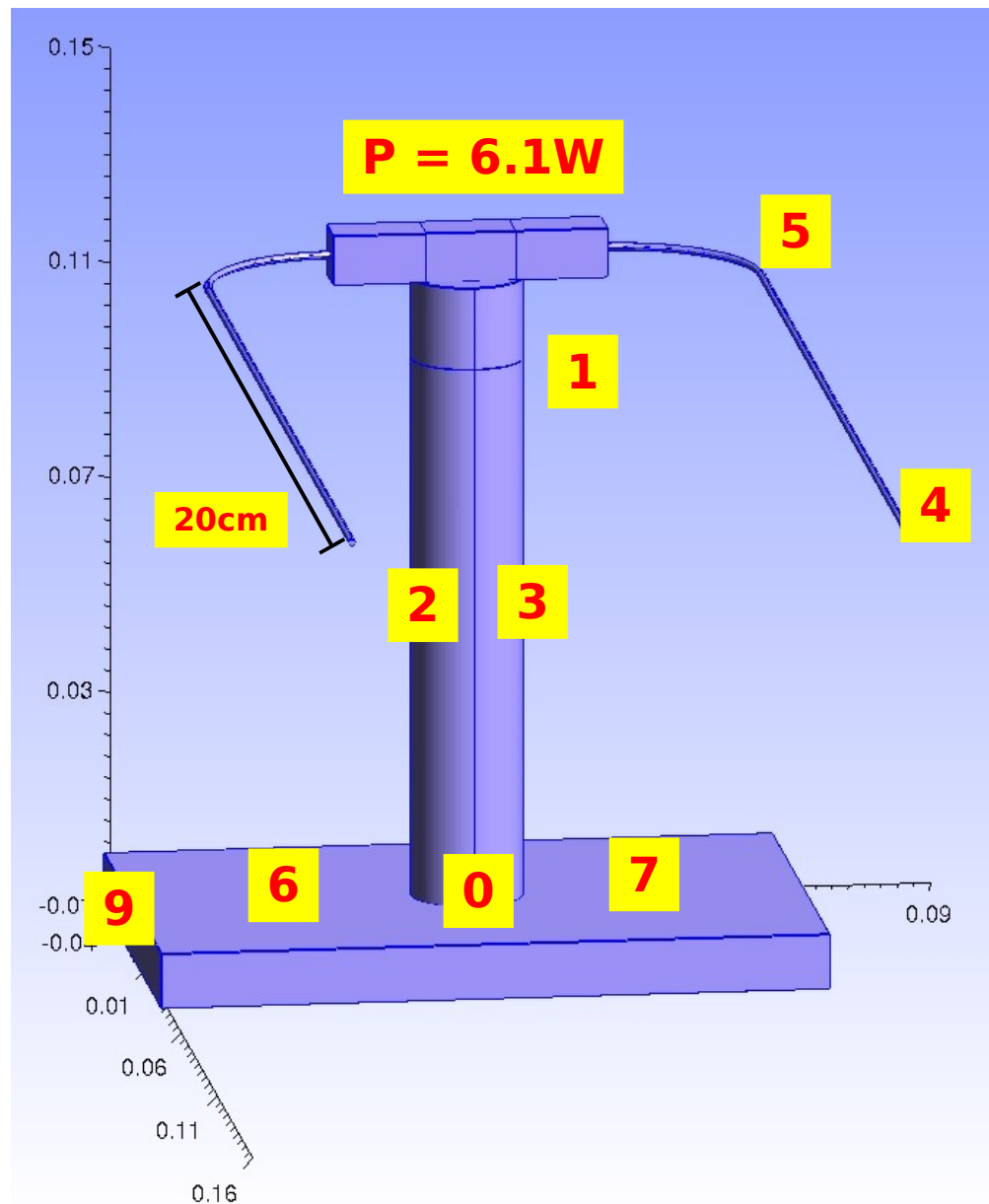
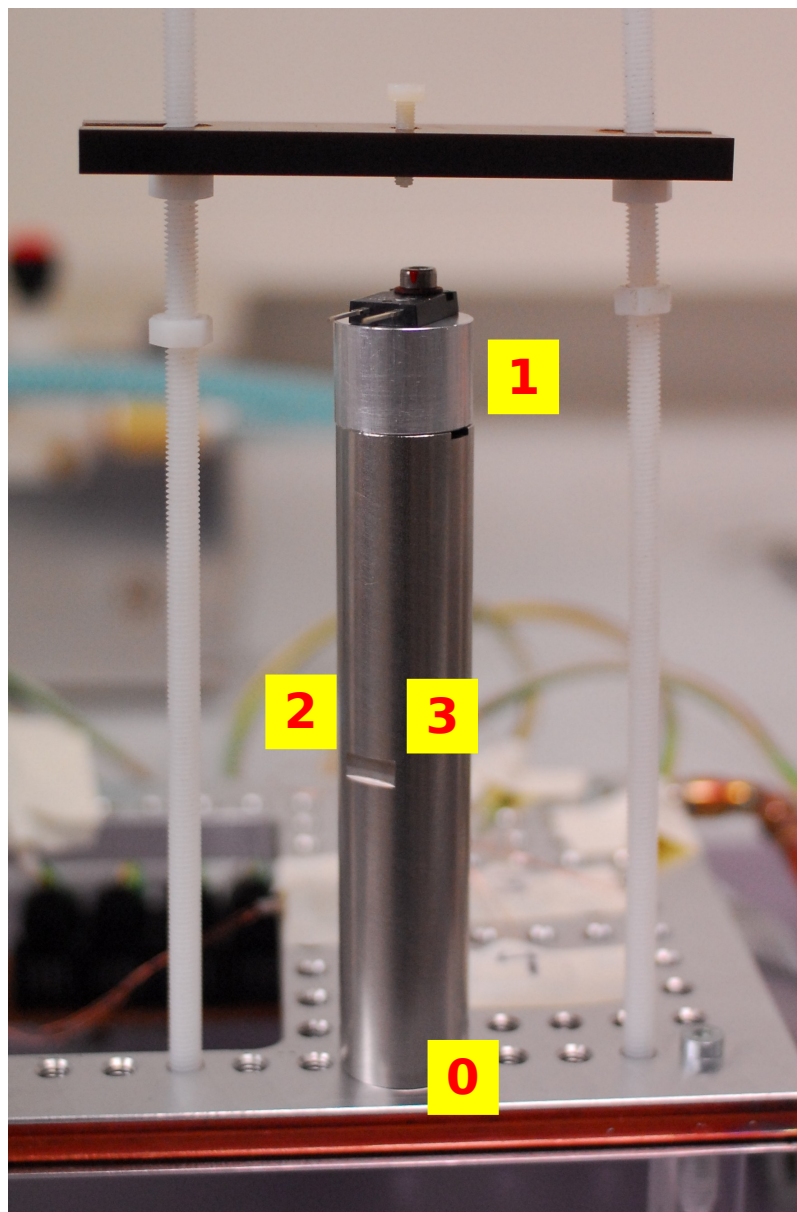
Residual plots:

$$T_{Ref} - T_{cal}$$



# Thermal conductivity measurement setup

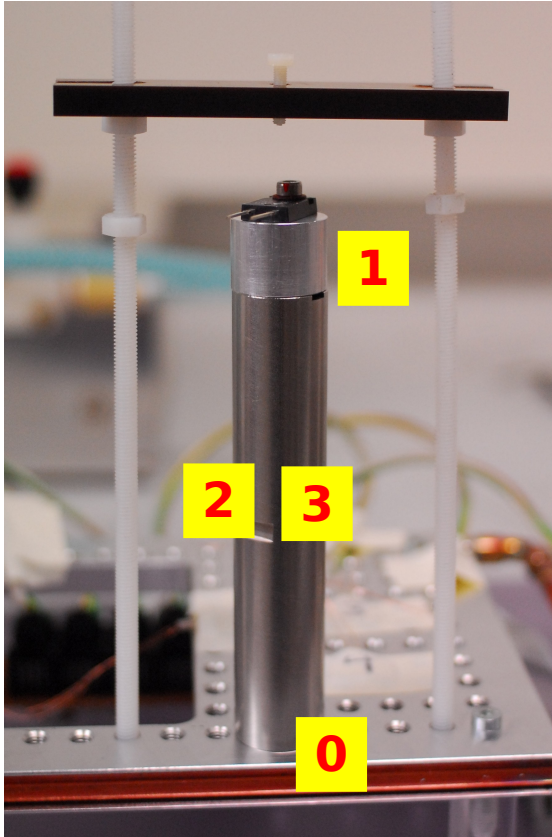
$$k = \frac{P}{A} \frac{\Delta x}{\Delta T}$$





# Sensor calibration results

## Aluminum ( $k \sim 150 \text{ W K}^{-1} \text{ m}^{-1}$ )



| Sensor | T(°C) | T(°C) | T(°C) |
|--------|-------|-------|-------|
| 0      | 4     | 12    | 22    |
| 1      | 12.5  | 20.25 | 30    |
| 2      | 8.4   | 16.4  | 25.6  |
| 3      | 8.9   | 16.65 | 25.5  |
| 4      | 23    | 2435  | 25.5  |
| 5      | 48    | 48    | 48    |
| 6      | 2.3   | 10.5  | 1935  |
| 7      | 2.3   | 10.5  | 19.5  |
| 9      | 1     | 10    | 19    |
| k      | 228   | 235   | 242   |

More than  
expected!!



**Non-uniform temperature gradient,**  
uniform temperature gradient expected if convection and  
radiation could be neglected.

# Equations

**Fourier's law**

$$\vec{q} = -k \nabla T$$

**Newton's law**

$$\frac{dQ}{dt} = -h (T_{env} - T(t)) ds$$

**Stefan – Boltzmann law**

$$\frac{dQ}{dt} = \epsilon \sigma (T(t)^4 - T_{env}^4) ds$$

$\vec{q}$  local heat flux ( $W/m^2$ )

$k$  material's conductivity ( $W/m \cdot K$ )

$T$  temperature of the object

$Q$  thermal energy

$h$  Heat transfer coefficient ( $W/m^2 k$ )

$ds$  surface area from where the heat is transferred

$T_{env}$  temperature of the environment

$\epsilon$  emissivity coefficient of the surface

$\sigma$  Stefan – Boltzmann constant

# Constraints and Coefficients

$$k_{table} = 130 \text{ W/mK (aluminum)}$$

$$k_{rod} = 170 \text{ W/mK (aluminum)}$$

$$k_{spreader} = 130 \text{ W/mK (aluminum)}$$

$$k_{wires} = 400 \text{ W/mK (copper)}$$

$$k_{res} = 5 \text{ W/mK (carbon paste)}$$

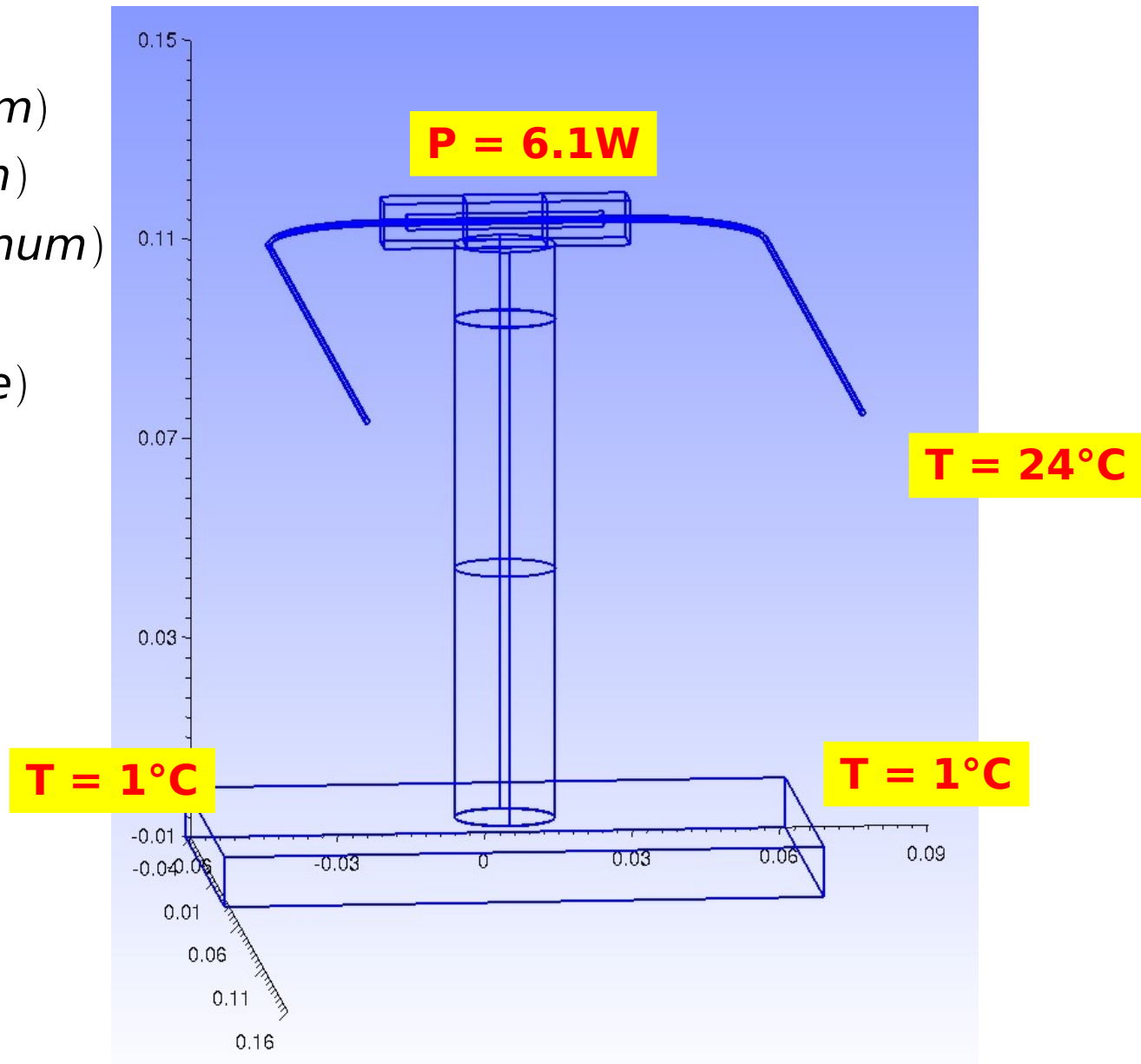
$$k_{res env} = 2 \text{ W/mK (ceramic)}$$

$$h_{air} = 15 \text{ W/m}^2\text{K}$$

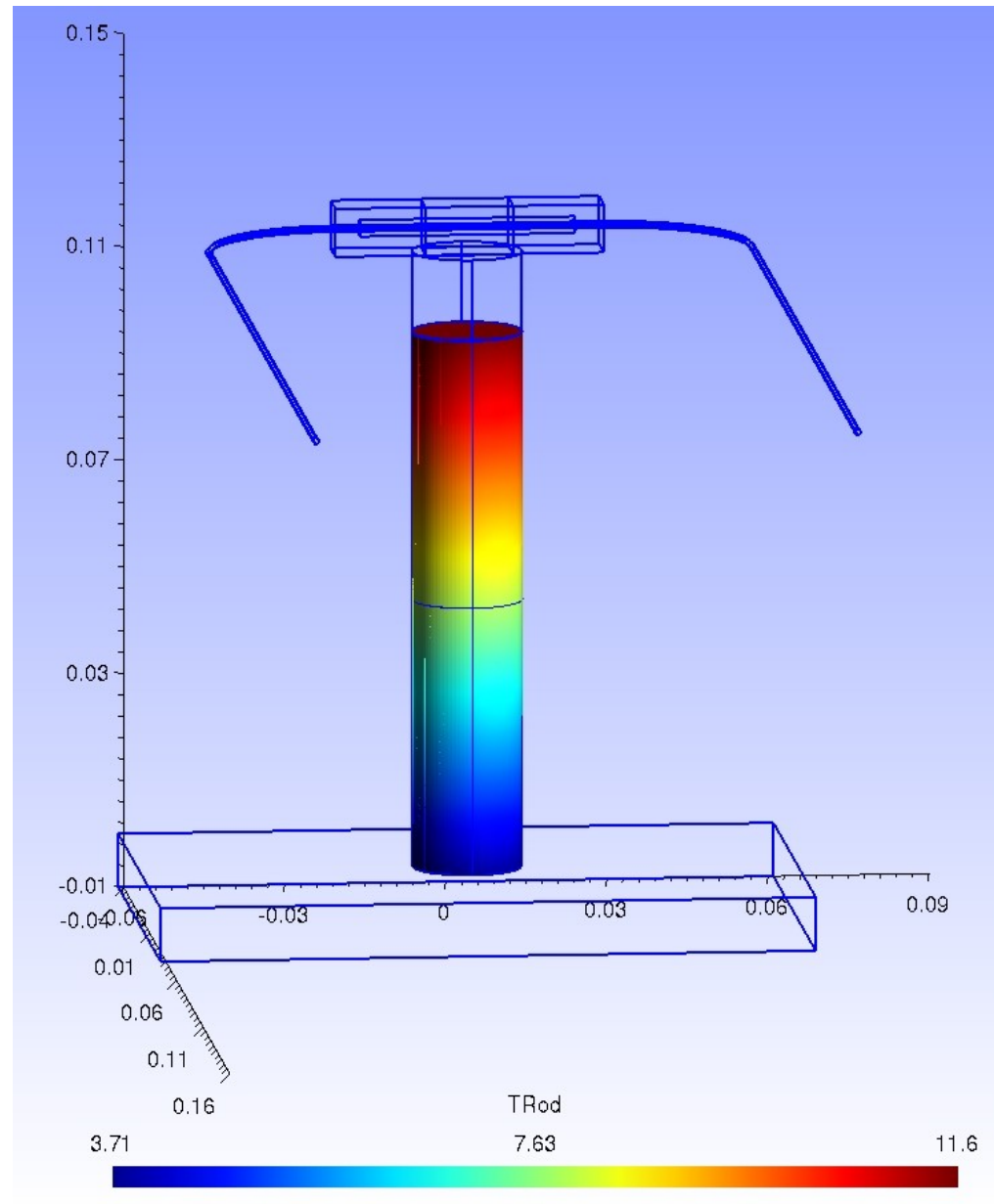
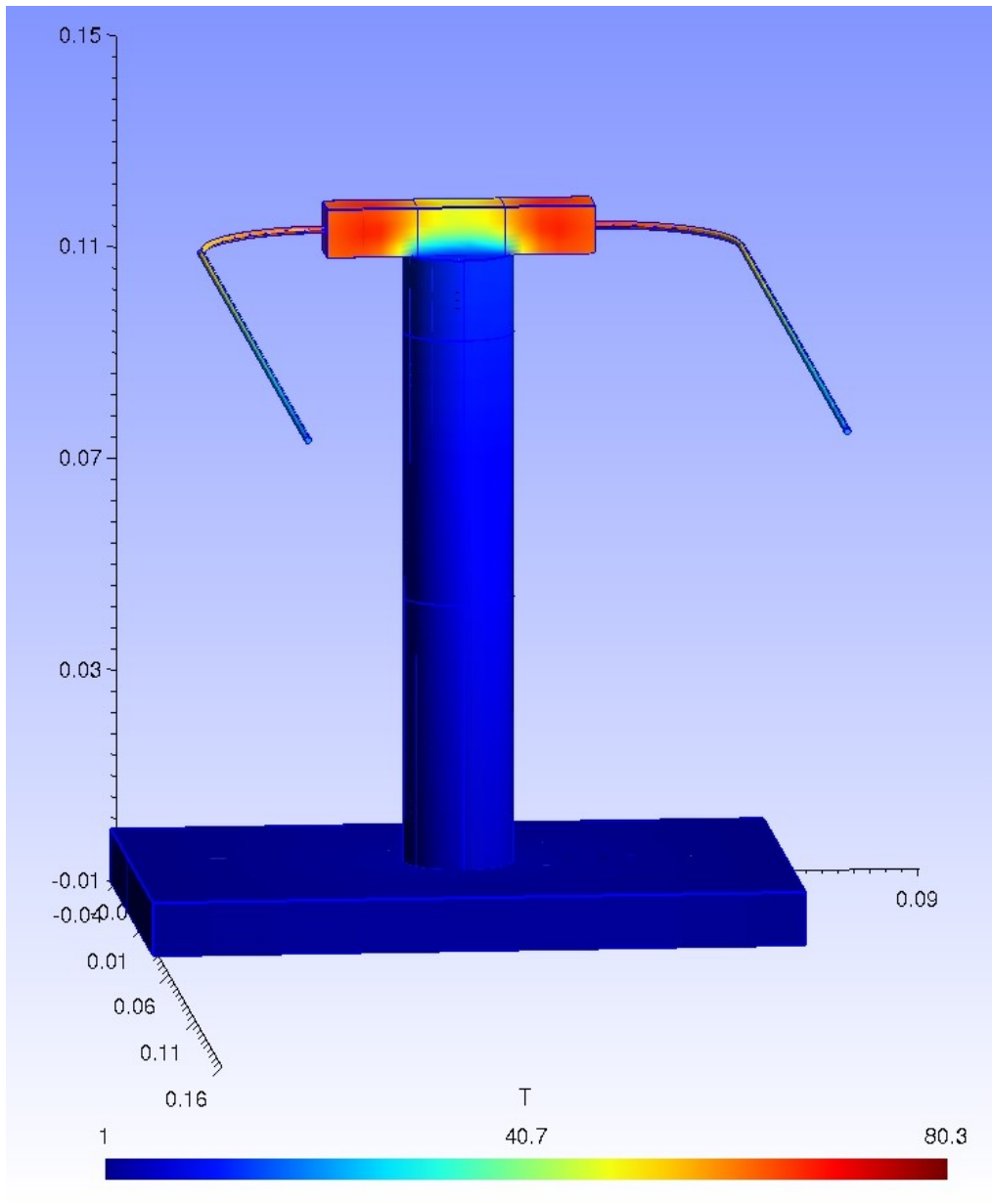
$$T_{air} = 15 \text{ K}$$

$$\epsilon_{metals} = 0.2$$

$$\epsilon_{ceramics} = 0.8$$



# Simulations results



**Qualitative agreement with data**

# Conclusions and Outlooks

## Achievements:

- Temperature sensors have been correctly calibrated.
- The setup for measuring the thermal conductivity coefficient has been tested.
- A quite satisfactory simulation has been developed.

## Things to be done:

- Fine tuning of the simulation parameters.
- Improvement of the setup (fixing air leak,...)



# Appendix

**Luminosity:**

$$\frac{dN}{dt} = \sigma L$$

where:

$N$  is the number of interactions;

$L$  is the instantaneous luminosity;

$\sigma$  is the total cross-section of the process.

In a storage ring collider:

$$L = f k \frac{N_1 N_2}{A}$$

where:

$f$  is the revolution frequency;

$k$  is the number of bunches in one beam in the storage ring;

$N_i$  is the number of particles in each bunch;

$A$  is the cross section of the beam.